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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1751**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mikito NISHI et al.

Group Art Unit: 1751

Application No.: 10/049,816

Examiner: J. Hardee

Filed: February 19, 2002

Docket No.: 111970

For: COOLANT, METHOD OF ENCLOSING COOLANT, AND COOLING SYSTEM

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the March 3, 2005 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.